

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of: )  
 Said Mansour et al. )  
 Serial No. 09/744,793 )  
 I.A. Filing Date: 30 July 1999 )  
 LOW TEMPERATURE OXYGEN GAS SENSOR )

I hereby certify that this correspondence is  
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James B. Myers Jr.

Name of Registered Representative

James B. Myers Jr.  
 Signature

January 16 2002  
 Date of Signature

**INFORMATION DISCLOSURE STATEMENT**

Hon. Commissioner for Patents  
 Washington, D.C. 20231

Sir:

Submitted herewith on the attached Information Disclosure Citation form is a list of documents of which Applicants are aware which they believe may be material to the examination of this application, and in respect of which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. Copies are not enclosed, in accordance with 37 C.F.R. §1.98(d), since they were previously cited by the Office in prior application PCT/US99/17422, which is relied upon for an earlier filing date. However, if it would assist the Examiner to have separate copies of the listed references for this application, Applicants will be happy to supply such copies upon request.

This Statement is being submitted before the first Office Action on the merits, and, therefore, it is believed that no fee is due. Should any fee be required, however, please charge such fee to Deposit Account No. 23-3030, but not to include the payment of issue fees which are or may become due.

Respectfully submitted,

By: James B. Myers Jr.  
 James B. Myers Jr., Reg. No. 42,021

Woodard, Emhardt, Naughton

Moriarty & McNett

Bank One Center/Tower

111 Monument Circle, Suite 3700

Indianapolis, Indiana 46204-5137

(317) 634-3456 Fax No. (317) 637-7561

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)  Page 1 of 2	ATTY. DOCKET NO. 7024-499	SERIAL NO. 09/486,301
	APPLICANT Said Mansour et al.	
	I.A. FILING DATE July 30, 1999	GROUP

**DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

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	D.K. Jang et al., "Solid Electrolyte Oxygen Sensor Operating at Low Temperatures," <i>Chemical Abstracts</i> , Vol. 122, No. 20, May 15, 1995, Abstract No. 242892x
	J. Vetrone et al., "Significance of Microstructure for MOCVD-Grown YSZ Thin Film Gas Sensor," <i>Chemical Abstracts</i> , Vol. 126, No. 1, January 6, 1997, Abstract No. 14057f
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	C.W. Sun et al., "Electrode Resistance of Pt/YSZ Oxygen Sensor and Response Behavior," <i>Chemical Abstracts</i> , Vol. 129, No. 24, December 14, 1998, Abstract No. 325375b
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	P.K. Schenck et al., "Imaging and Gasdynamic Modeling of Pulsed Laser Film Deposition Plumes," <i>Opt. Eng.</i> , Vol. 35, No. 11, November 1996, 3199-3205, <b>Abstract</b>
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EXAMINER	DATE CONSIDERED
<p><b>*EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	

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